



Figure 1

5

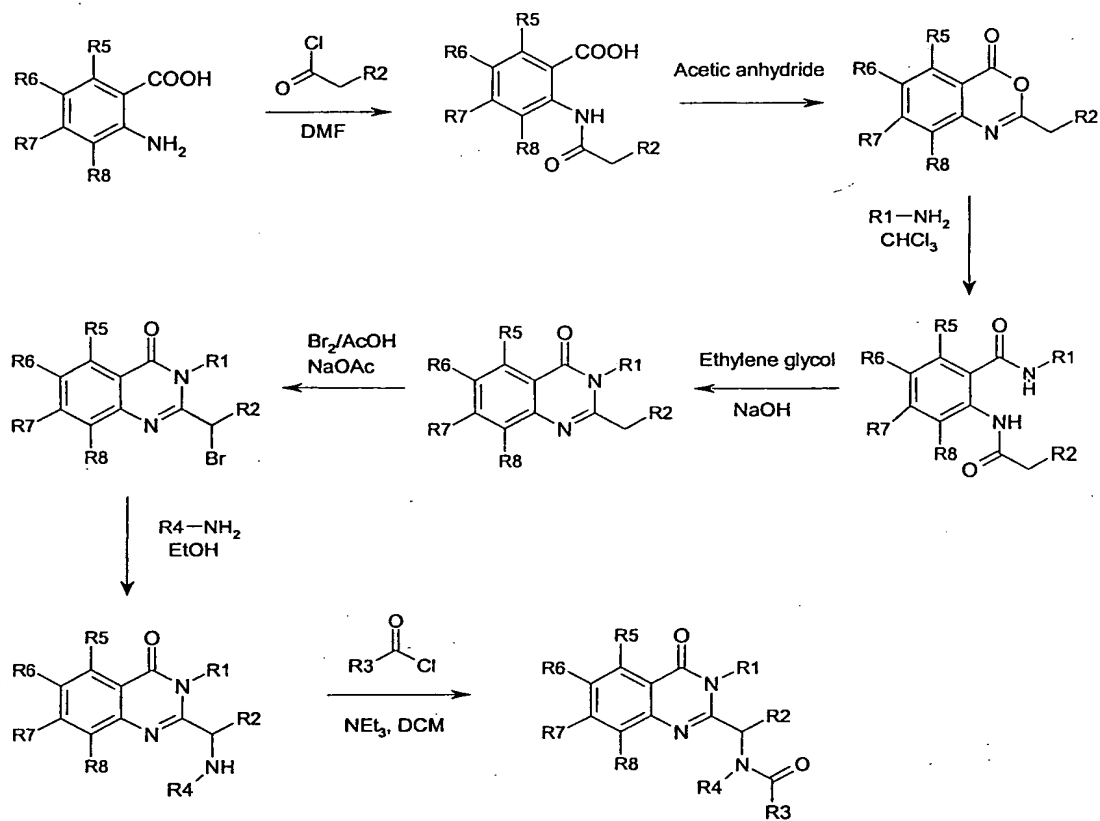


Figure 2

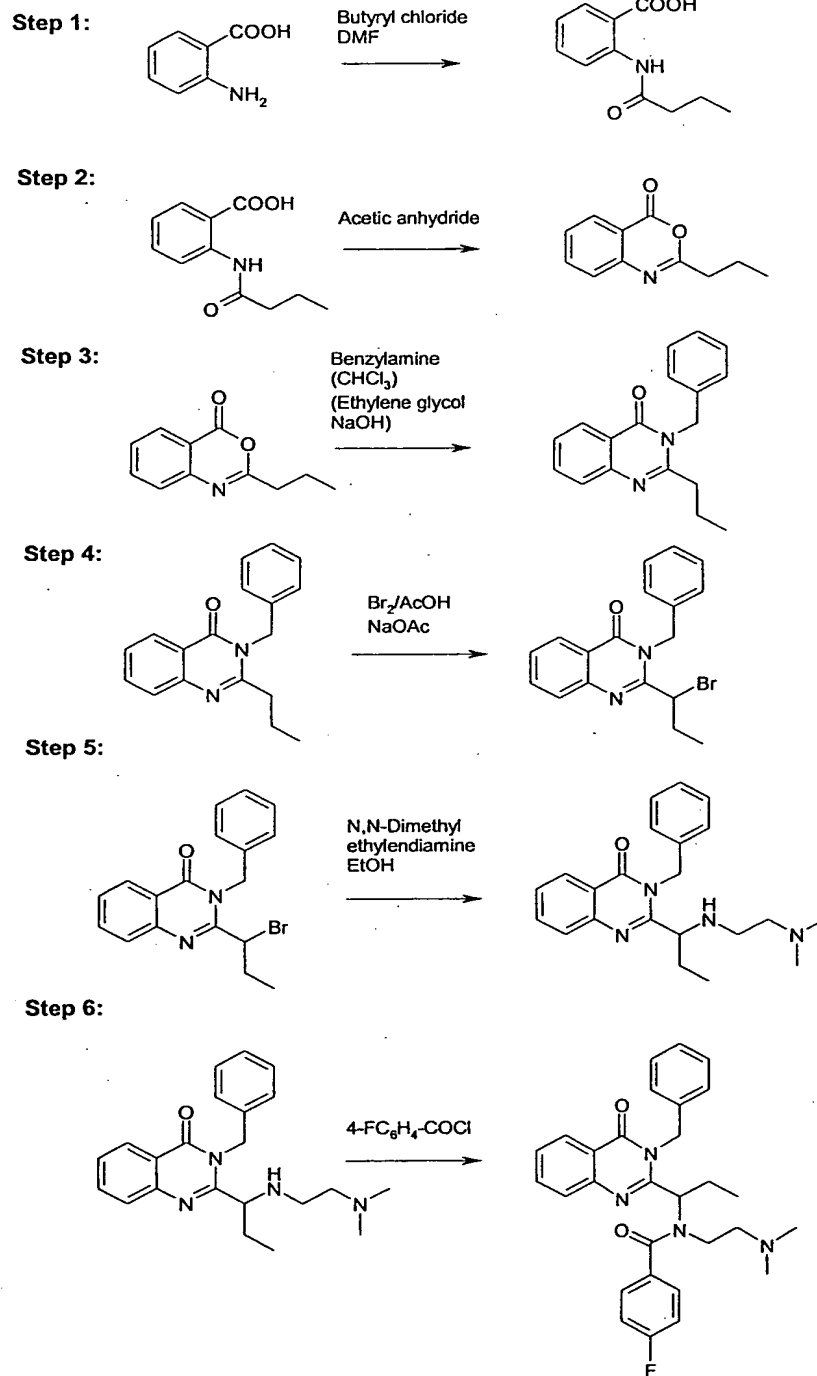


Figure 3

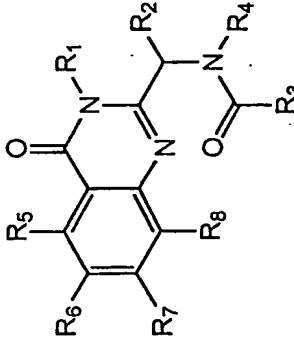
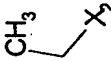
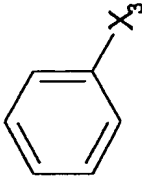
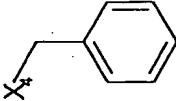

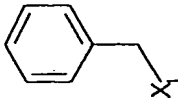

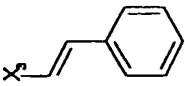
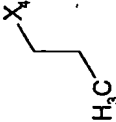
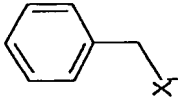

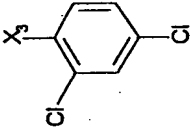
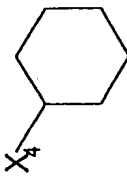
								
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

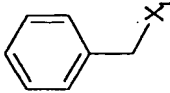

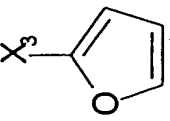
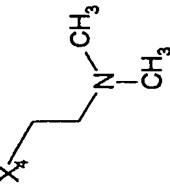
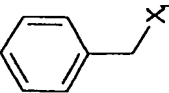

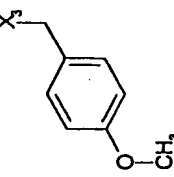
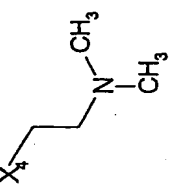
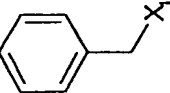
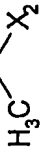
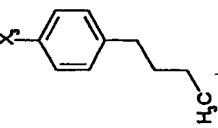
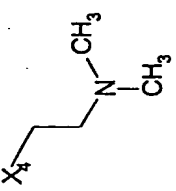
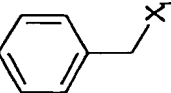

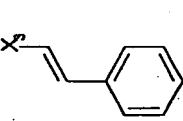
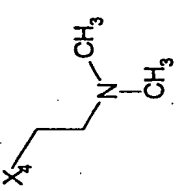
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM



Figure 3 (continued)

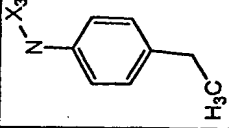
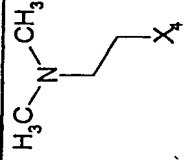
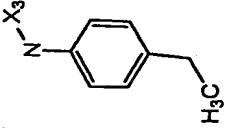
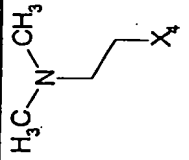
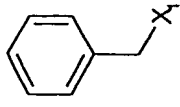
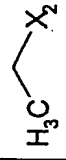
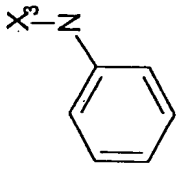
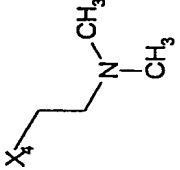
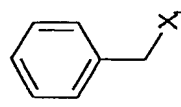
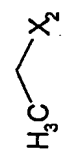
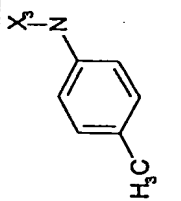
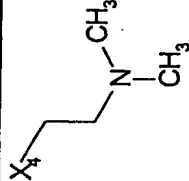
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
	X <sub>2</sub> -CH <sub>3</sub>					X <sub>7</sub> -Cl		%I > 35% @ 40 uM
	X <sub>2</sub> -CH <sub>3</sub>					X <sub>7</sub> -Cl		%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
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Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

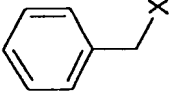

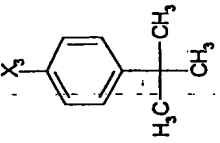
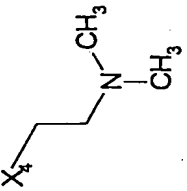
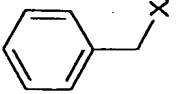

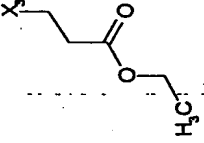
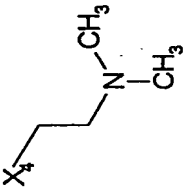
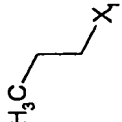

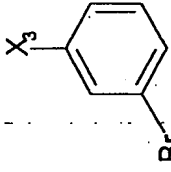
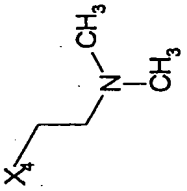
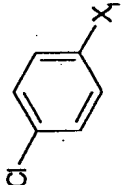

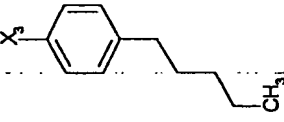
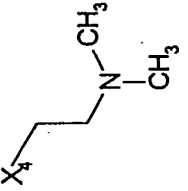
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM



Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
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Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
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								%I > 35% @ 40 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

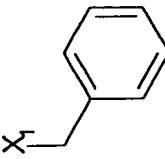

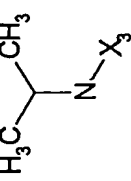
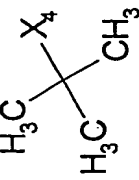
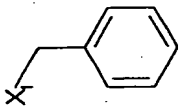
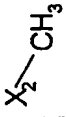

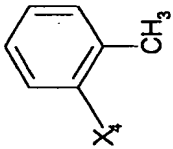
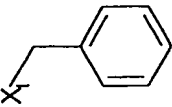
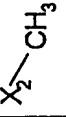
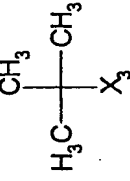
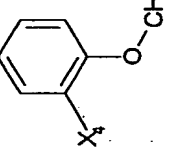
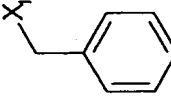
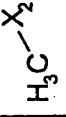
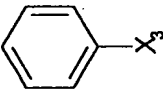
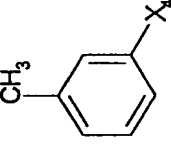
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

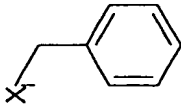
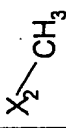
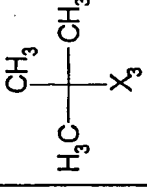
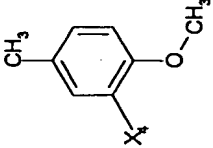
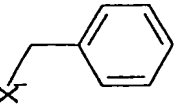
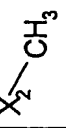
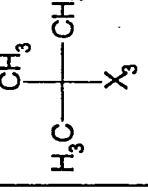
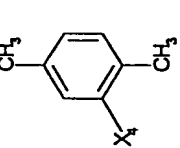
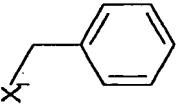
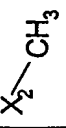
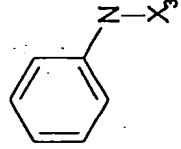
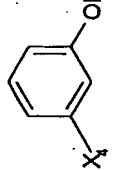
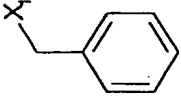

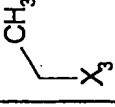
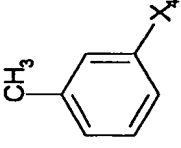
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

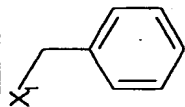
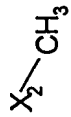
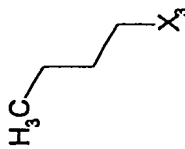
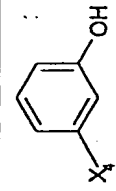
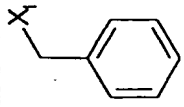
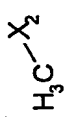
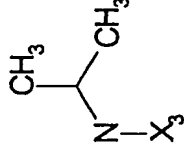
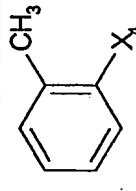
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								%I > 35% @ 40 uM
								%I > 35% @ 40 uM

Figure 3 (continued)

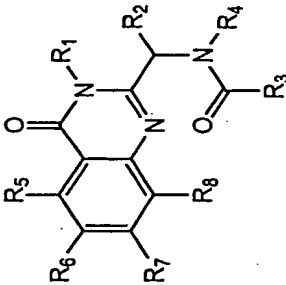
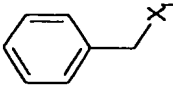
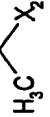
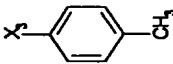
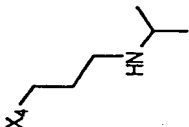

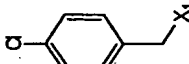
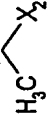

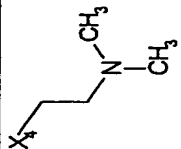

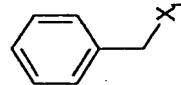


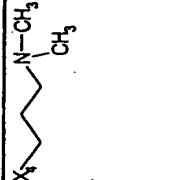

									
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity	
								IC50 < 100 nM	
								IC50 < 100 nM	
								IC50 < 100 nM	

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM



Figure 3 (continued)

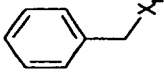


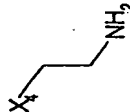

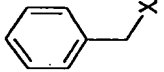

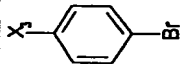
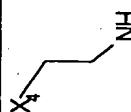

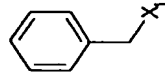
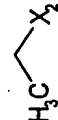
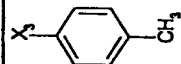


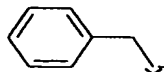


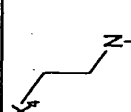

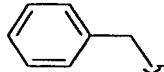


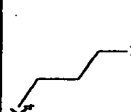

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

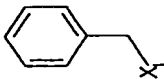


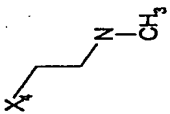

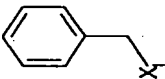


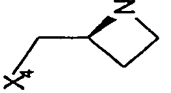

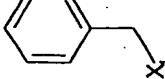


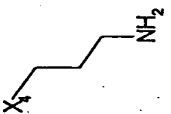

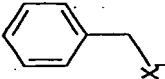


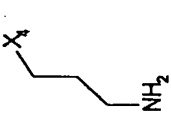

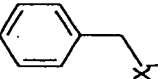


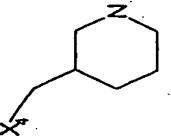

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

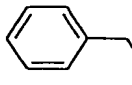


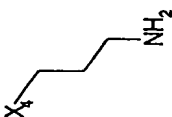

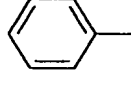


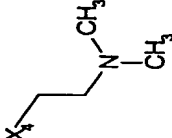

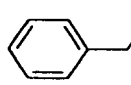


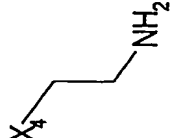
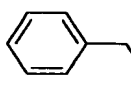

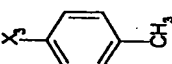
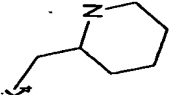

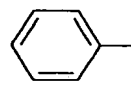
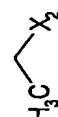
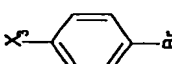
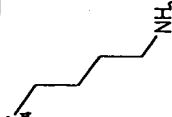

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM



Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 < 100 nM
								IC50 < 100 nM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM



Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM



Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 100 nM-1 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

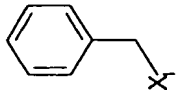

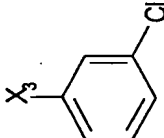
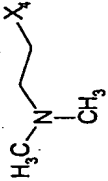

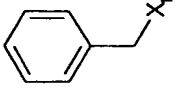
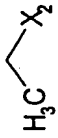
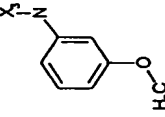
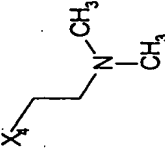
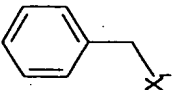

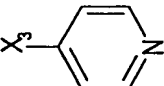
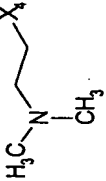

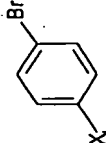

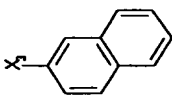
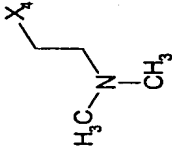
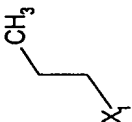

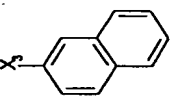
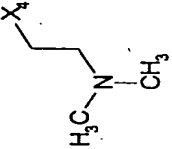
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

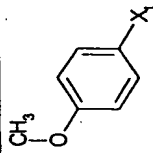

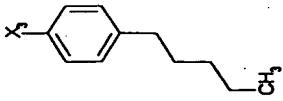
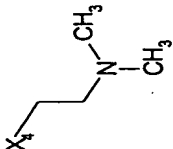

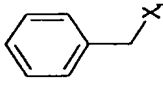
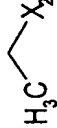
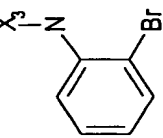
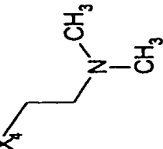
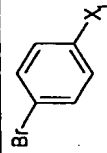

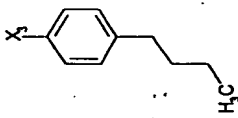
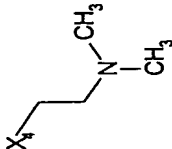
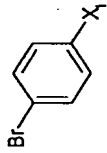

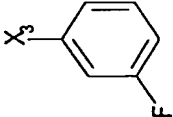
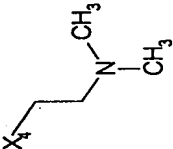
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM



Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 $\mu$ M-10 $\mu$ M
								IC50 = 1 $\mu$ M-10 $\mu$ M
								IC50 = 1 $\mu$ M-10 $\mu$ M
								IC50 = 1 $\mu$ M-10 $\mu$ M
								IC50 = 1 $\mu$ M-10 $\mu$ M

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM

Figure 3 (continued)

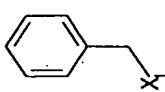

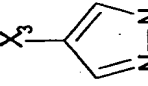
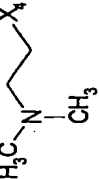

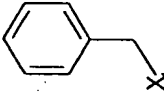

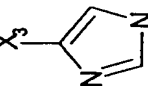
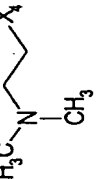

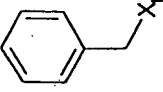

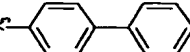
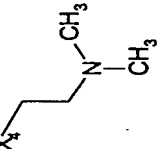
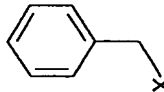


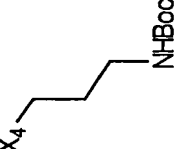

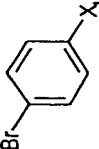

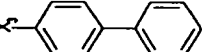
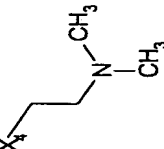
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 1 uM-10 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM

Figure 3 (continued)

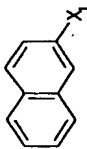

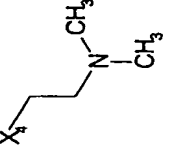
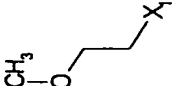
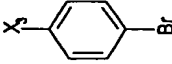
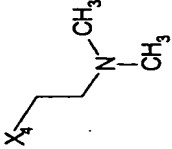
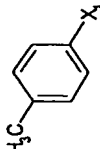

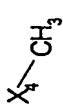

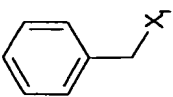
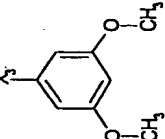
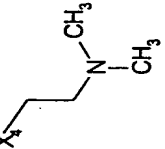
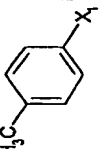



R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
	H <sub>3</sub> C-X <sub>2</sub>							IC50 = 10 uM-50 uM
	H <sub>3</sub> C-X <sub>2</sub>							IC50 = 10 uM-50 uM
	H <sub>3</sub> C-X <sub>2</sub>							IC50 = 10 uM-50 uM
	H <sub>3</sub> C-X <sub>2</sub>							IC50 = 10 uM-50 uM
	H <sub>3</sub> C-X <sub>2</sub>							IC50 = 10 uM-50 uM



Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM
								IC50 = 10 uM-50 uM

Figure 3 (continued)


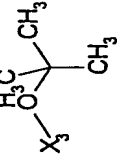
R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								IC50 = 10 uM-50 uM

Figure 3 (continued)

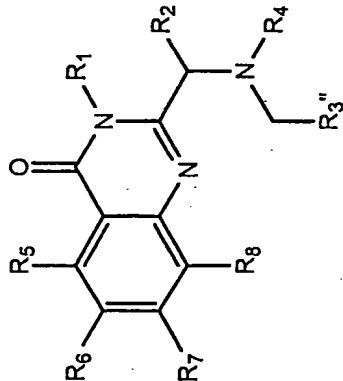
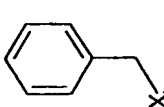
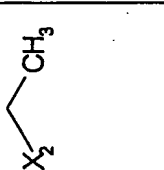
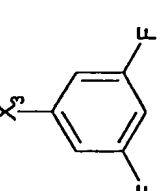
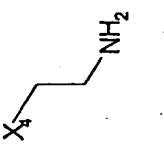
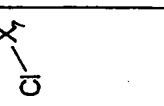
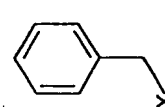
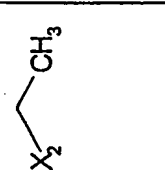
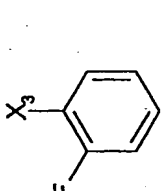
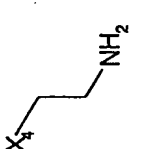
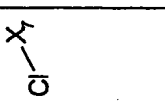
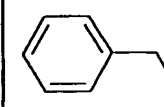
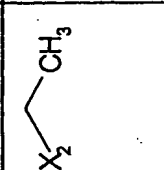
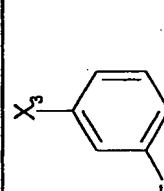
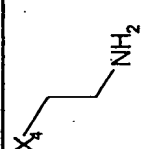
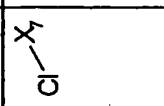
									
R <sub>1</sub>	R <sub>2</sub>	R <sub>3''</sub>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity	
								Ki < 100 nM	
								Ki < 100 nM	
								Ki < 100 nM	

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM



Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> <sup>''</sup>	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki < 100 nM
								Ki < 100 nM
								Ki < 100 nM
								Ki = 100 nM-1 uM
								Ki = 100 nM-1 uM

Figure 3 (continued)

R <sub>1</sub>	R <sub>2</sub>	R <sub>3</sub> "	R <sub>4</sub>	R <sub>5</sub>	R <sub>6</sub>	R <sub>7</sub>	R <sub>8</sub>	Activity
								Ki = 100 nM-1 uM
								Ki = 100 nM-1 uM
								Ki = 100 nM-1 uM
								Ki = 1 uM-10 uM
								Ki = 1 uM-10 uM



Figure 4: Asymmetric Synthesis

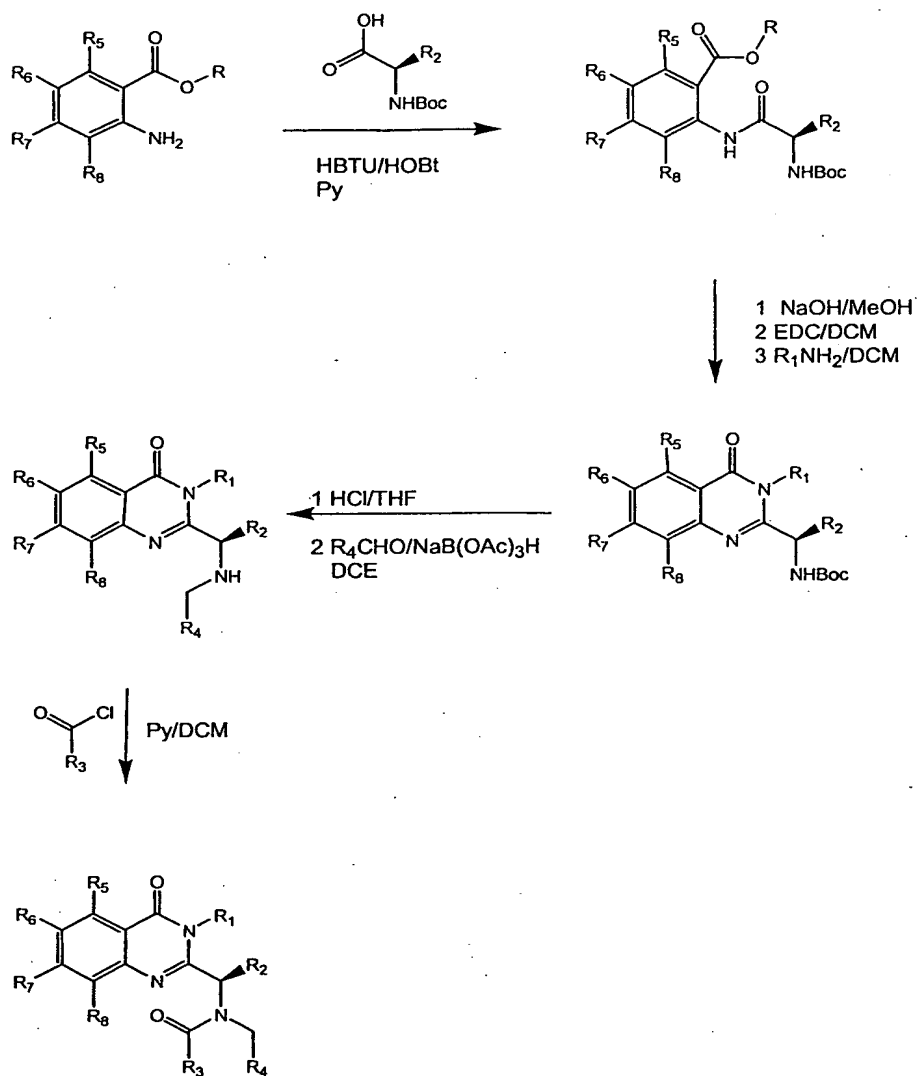
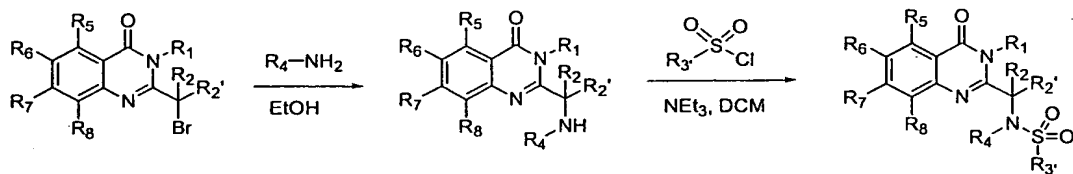


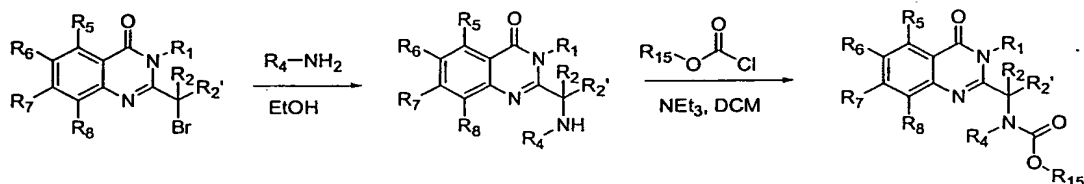
Figure 5

Figure 5a: Sulfonamide Synthesis



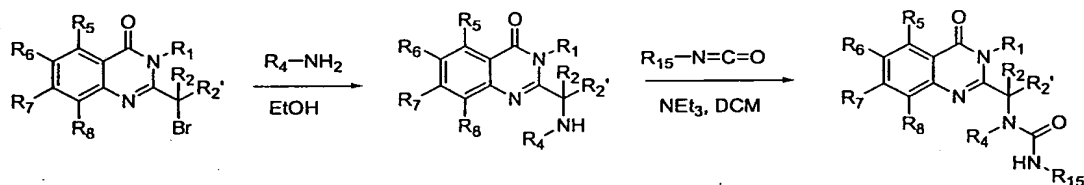
5

Figure 5b: Carbamate Synthesis



10

Figure 5c: Urea Synthesis



15 Figure 5d: Primary and Secondary Amine R4 Synthesis

